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Dana Weinstein, *Purdue University, USA*

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• IEEE Electron Devices Society Robert Bosch
Micro and Nano Electro Mechanical Systems Award**

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Sumitomo Precision Products Co., Ltd., JAPAN

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¹Northwestern Polytechnical University, CHINA, ²Second Affiliated Hospital of Xi'an Jiaotong University, CHINA, and ³Hangzhou Dianzi University, CHINA

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f - MEMS Physical and Chemical Sensors
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g - MEMS/NEMS for Optical, RF and Electromagnetics
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